

**Notice of References Cited**

Application/Control No.

10/777,432

Applicant(s)/Patent Under  
Reexamination  
KIM ET AL.

Examiner

Diego Herrera

Art Unit

2617

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0192017	09-2005	Choi et al.	455/450
*	B	US-2005/0089008	04-2005	Choo et al.	370/349
*	C	US-2003/0147427	08-2003	Sekino et al.	370/503
*	D	US-7,039,425	05-2006	Mazawa et al.	455/456.4
*	E	US-5,953,676	09-1999	Berry et al.	455/564
*	F	US-5,983,099	11-1999	Yao et al.	455/426.1
*	G	US-5,822,694	10-1998	Coombes et al.	455/433
*	H	US-6,097,951	08-2000	Ernam et al.	455/433
*	I	US-7,096,026	08-2006	Thorson et al.	455/450
*	J	US-7,058,042	06-2006	Bontempi et al.	370/338
*	K	US-6,907,022	06-2005	Dorenbosch, Jheroen Pieter	370/338
*	L	US-7,058,033	06-2006	Dantu et al.	370/331
*	M	US-5,613,201	03-1997	Alford et al.	455/18

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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